



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Hisashi OHTANI et al. )  
Serial No. 09/550,598 )  
Filed: April 17, 2000 )  
For: SEMICONDUCTOR DEVICE )  
AND PROCESS FOR )  
PRODUCING THE SAME )

Art Unit: 2814  
Examiner: P. Cao

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 14, 2003.

*Paul M. Stamps*

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

# 20 / D  
marsha  
8/12/03

In response to the Official Action dated March 12, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.

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